

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Examiner: Arleen M. Vazquez
Yukihiro Morita et al.	Group Art Unit: 2829
Serial No.: 10/568,985	Confirmation No. 3592
Filed: February 21, 2006	
For: INSULATING FILM MEASURING DEVICE, INSULATING FILM MEASURING METHOD, INSULATING FILM EVALUATING DEVICE, INSULATING FILM EVALUATING METHOD, SUBSTRATE FOR ELECTRIC DISCHARGE DISPLAY ELEMENT, AND PLASMA DISPLAY PANEL	July 25, 2008 Costa Mesa, California 92626

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant wishes to bring to the attention of the U.S. Patent Office the following reference, which was found during the prosecution of a corresponding Japanese patent application:

Japanese Publication No. 2001-167726 w/English Abstract

A copy of this reference and form PTO-A820 are attached.

The undersigned attorney hereby certifies that each item contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart international application not more than three months prior to filing this statement.

If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

Very truly yours,

SNELL & WILMER LLP



Joseph W. Price, Reg. No. 25,124
600 Anton Boulevard, Suite 1400
Costa Mesa, CA 92626
Tel: 714-427-7420
Fax: 714-427-7799